

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 248212US2		SERIAL NO. New Application	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Masao MIYAMURA			
				FILING DATE Herewith		GROUP 1709	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
/MB/	AA	5,169,509	12/08/92	Rudolf LATZ, et al.	204	298.03	
/MB/	AB	5,082,546	01/21/92	Joachim SZCZYRBOWSKI, et al.	204	298.08	
/MB/	AC	6,103,320	08/15/00	Shigeharu MATSUMOTO, et al.	427	535	
/MB/	AD	4,851,095	07/25/89	Michael A. SCOBAY, et al.	204	192.12	
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
					YES	NO	
/MB/	AO	8-511830	12/10/96	Japan		x	
/MB/	AP	11-256327	09/21/99	Japan		x	
/MB/	AQ	2-269514	11/02/90	Japan (with English Abstract, Corresponding U.S. Patent 5,082,546)		x	
/MB/	AR	11-279758	10/12/99	Japan (with English Abstract, Corresponding U.S. Patent 6,103,320)		x	
/MB/	AS	4-325680	11/16/92	Japan (with English Abstract, Corresponding U.S. Patent 5,169,509)		x	
/MB/	AT	3-229870	10/11/91	Japan (with English Abstract, Corresponding U.S. Patent 4,851,095)		x	
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
/MB/	AW	R. LAIRD, et al., "Cosputtered Films of Mixed TiO ₂ /SiO ₂ ", J. VAC. SCI. TECHNOL., Vol. A10, No. 4, July/August 1992, p. 1908-1912					
	AX						
	AY						
	AZ						<input type="checkbox"/> Additional References sheet(s) attached
Examiner /Michael Band/					Date Considered 04/19/2007		
<small>*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							